

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant	:	Matthew G. Goodman <i>et al.</i>
Application No.	:	10/775,522
Filed	:	February 10, 2004
For	:	TWO-STAGE LOAD FOR PROCESSING BOTH SIDES OF A WAFER
Examiner	:	Sylvia MacArthur
Group Art Unit	:	1763
Confirmation No.	:	1057

AMENDMENT UNDER 37 C.F.R. 1.111**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

This paper is responsive to an Office Action mailed August 24, 2006 and a Notice of Non-Compliant Amendment mailed February 12, 2007. A response is timely filed within the 30-day shortened statutory period by March 14, 2007.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.